

An Evolutionary Approach to Physics-based Modelling of Piezoelectric Actuators

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Abstract

The objective of this research is to improve physics-based models of piezoelectric actuators through developing a global parameter identification method for the models and introducing a new high performance model. Piezoelectric actuators produce nano-metre scale displacements making them the dominant actuators in nanopositioning applications. In nanopositioning, the control of actuators' displacement requires highly accurate displacement sensors. The sensors are expensive and difficult, if not impossible, to use. Therefore, the models are employed to estimate the displacement of piezoelectric actuators, using the voltage across them, without any displacement sensors. Accordingly, several mathematical models have been developed to estimate the displacement of piezoelectric actuators. However, due to the nonlinear behaviour of the actuators, the models cannot capture their behaviour precisely. Therefore, developing a model to simulate the nonlinear behaviour of the actuator would constitute an important contribution to the development of high precision sensorless nanopositioning systems. Models can also be used in control system design.

To model piezoelectric actuators, this research utilises physics-based models that have a small number of parameters compared with standard black box models of piezoelectric actuators minimising the computation efforts in real-time applications. In this thesis, the physics-based models are enhanced by dealing with two main diagnosed weaknesses of these models: (1) the lack of a global parameter identification method and, (2) the relatively low accuracy of the models due to their inadequate mathematical structure.

The method for identifying the parameters of the physics-based models is one of the main challenges for these models. In general, the parameters of physics-based models are determined by non-optimal *ad-hoc* methods. Hence, this research adopts a standard, optimal and global (*non-ad-hoc*) method to identify the parameters of the nonlinear models of the piezoelectric actuators.

Another challenge for the physics-based models of piezoelectric actuators is the relatively low accuracy of the models compared with the black box models, partially arising from the rather simple mathematical structure and a small number of parameters of these models. Therefore, improving the model structure will increase the model accuracy. To address this matter, complementary terms/inputs are added to a physics-base model constructing an enhanced structure for the model. The new model doubles the estimation accuracy of the original model

and results in accuracies comparable with those of the best reported models of piezoelectric actuators.

The proposed ideas are substantiated to increase the applicability and accuracy of the models of piezoelectric actuators. From the range of physics-based models, the Voigt model is a particular focus for this research. The Voigt model can capture the rate-dependent and nonlinear behaviour of piezoelectric actuators. Furthermore, this model has been reported to be adequate for a broad excitation frequency range (1-1000) H_z . However, the proposed ideas are easily extendable to other physics-based models of piezoelectric actuators.

Statement of Originality / Declaration by author

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Nomenclature

Abbreviations

ANN	Artificial neural network
NARMAX	Nonlinear autoregressive moving average with exogenous inputs
AFM	Atomic force microscope
PZT	Lead zirconate titanate
PI	Parandtl-Ishlinski
sgn	Sign
exp	Exponential
SQP	Sequential quadratic programming
OSP	One step prediction
GA	Genetic algorithm
MAC	Minimum of absolute change
Max	Maximum value
Min	Minimum value
MAX	Maximum of absolute error
MAE	Mean of absolute error

Symbol

Ε	Electric field
Т	Stress vector
S	Strain vector
D	Electrical induction

S ^E	Mechanical flexibility
$\varepsilon^{^{T}}$	Electrical permittivity
d	Piezoelectric coefficient
В	External magnetic field
y(t)	Piezoelectric displacement
$\mu(lpha',eta')$	Preisach density function
lpha',eta'	Voltage representations in the Preisach model
y _{max}	Local maximum of the piezoelectric displacement
y _{min}	Local minimum of the piezoelectric displacement
y_{ext}	Local extremum of the piezoelectric displacement
$V_{ m max}$	Local maximum of the piezoelectric voltage
V_{\min}	Local minimum of the piezoelectric voltage
V _{ext}	Local extremum of the piezoelectric voltage
H(i)	Backlash (play) operator
i	Width of the backlash operator
ω	Slope of the backlash operator
r	Half-width of the input voltage
<i>y</i> ₀	Initial displacement of piezoelectric actuator
j	Number of backlash operators/widths
μ	Friction coefficient
Ν	Normal force
k	Spring stiffness

b	Spring damping coefficient
F	External force (reaction force)
W _i	Saturation force
<i>g</i> ₁ , <i>g</i> ₂	Hysteresis slopes
α, λ, β	Sigmoid parameters
F_c	Initial applied force
n	Number of elements
A_{th}	Theoretical hysteresis loop areas
A _{hyst}	Experimental hysteresis loop areas
l	Number of estimations
т	Number of bits
$p_{ m b}$	Parameter (gene) value
p_{\min}	Minimum value of each parameter (gene)
p_{\max}	Maximum value of each parameter (gene)
T ₁	Internal length of the piezoelectric stack
T ₂	External length of the piezoelectric stack
W_1	Internal width of the piezoelectric stack
W_2	External width of the piezoelectric stack
Н	Height of the piezoelectric stack
L	Length of the lead wire
ts	Sampling time
<i>r</i> _y	Output order
θ	Parameter vector

- $\varphi(t)$ Regression vector
- *A* Voltage amplitude
- f Voltage frequency